

Managing Thermal System Make-up and Treatment

February 9, 2016

Jim Riley, CEM
Nathan Jones



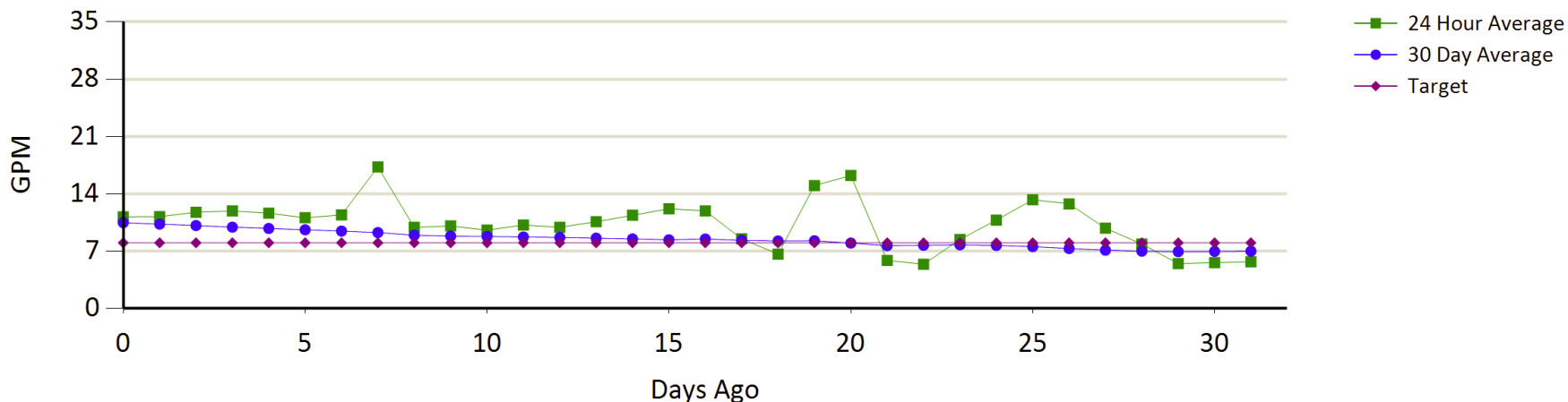
Thermal Systems Make-up Monitoring

Thermal Loop Make-up (GPM)	24 Hour Average	30 Day Average	Target (1%)	%Over / (Under) Target
Main Campus				
Chilled Water	11.18	10.46	8	31
Heating Hot Water	13.05	12.33	3	311
West Campus				
Chilled Water	13.91	13.88	11	26
Heating Hot Water	5.46	11.45	3	282

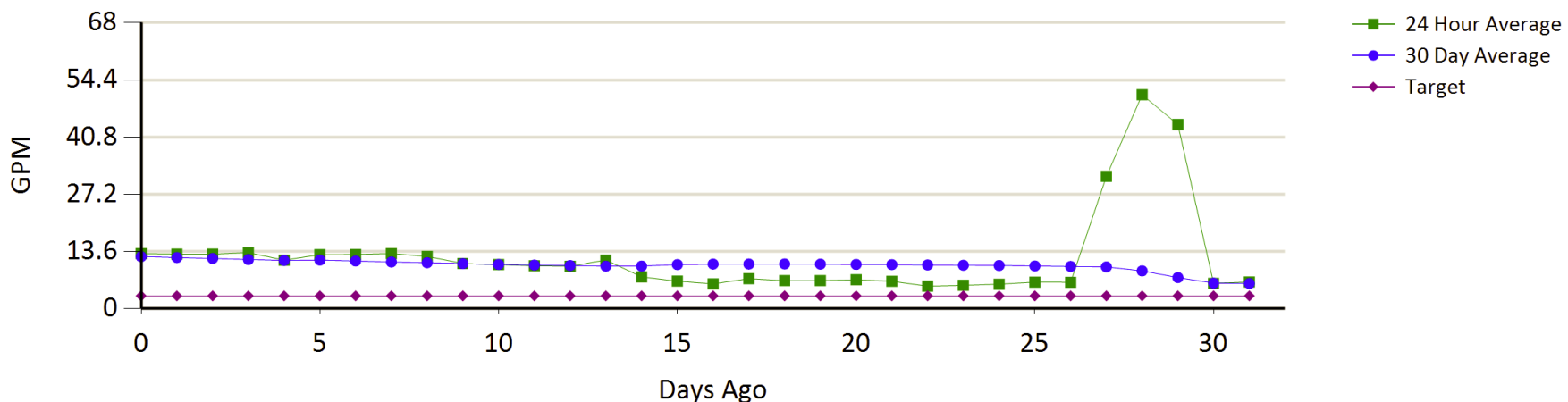
1/26/2016 6:00:00 AM

Thermal System Make-up Main Campus

Main Campus Chilled Water Make Up - GPM

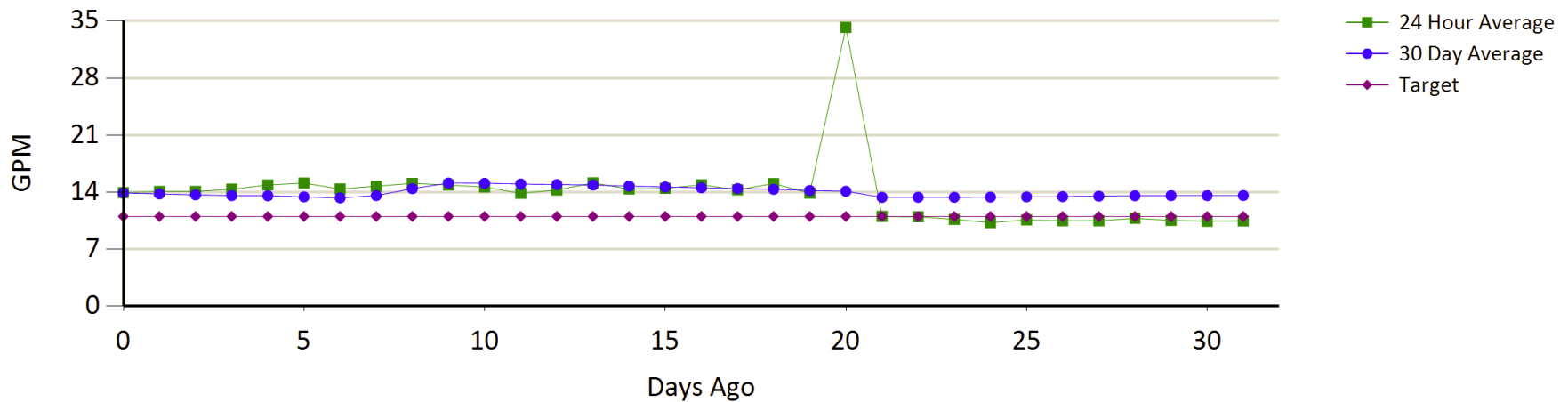


Main Campus Heating Hot Water Make Up - GPM

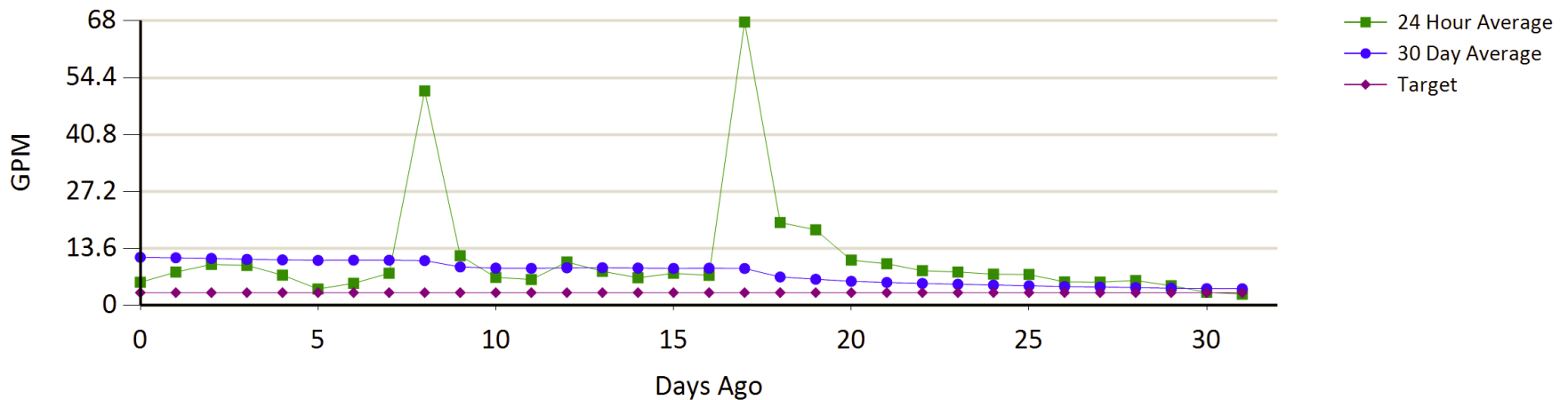


Thermal System Make-up West Campus

West Campus Chilled Water Make Up - GPM

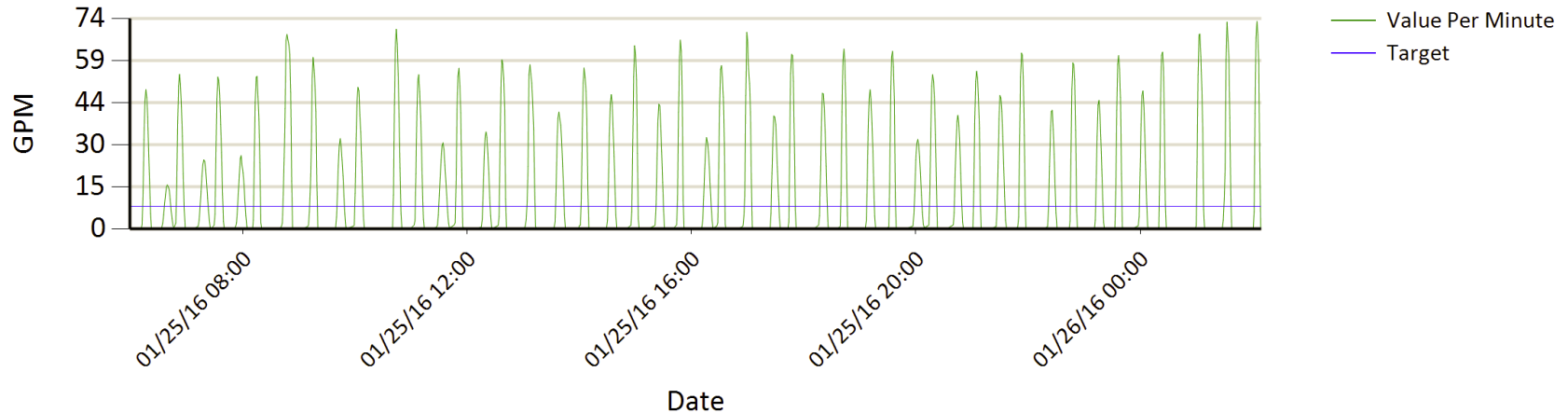


West Campus Heating Hot Water Make Up - GPM

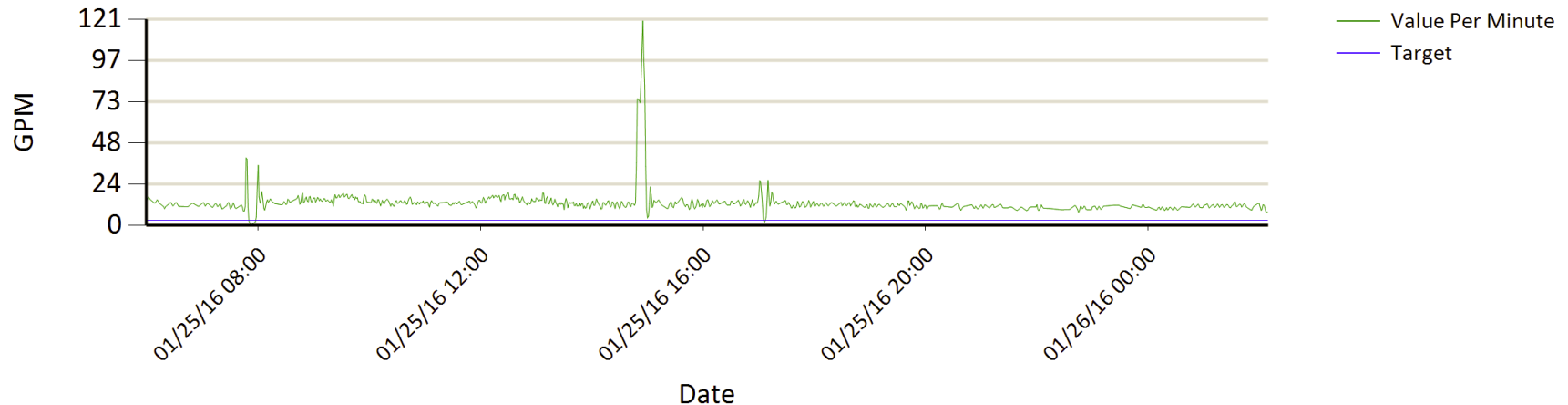


Thermal System Make-up by Minute Main Campus

Main Campus Chilled Water Make Up - GPM

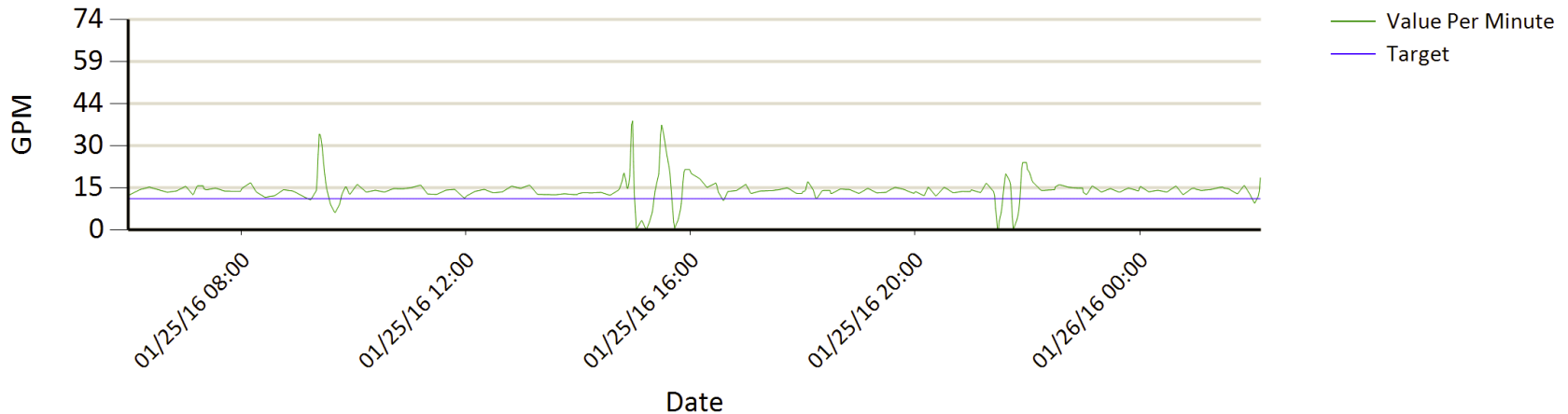


Main Campus Heating Hot Water Make Up - GPM

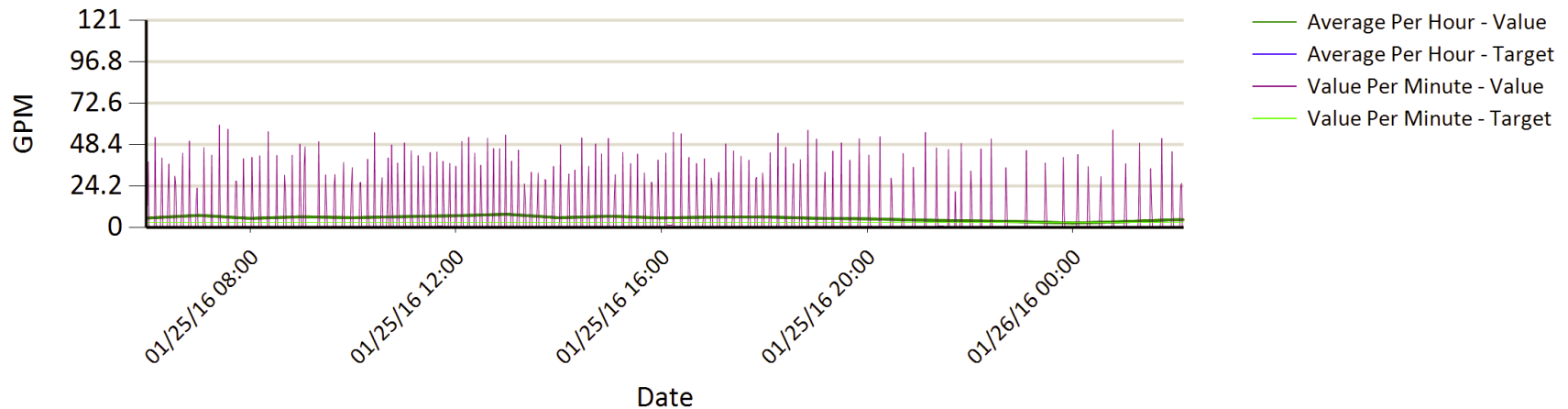


Thermal System Make-up by Minute West Campus

West Campus Chilled Water Make Up - GPM



West Campus Heating Hot Water Make Up - GPM



Thermal System Water Treatment

Chilled Water Treatment

- Phosphate-based
- GE GenGard GN7110

Heating Hot Water Treatment

- Molybdate-based
- GE CorrShield MD4103

